

## Ac-Dc-Dc Converter Using Silicon Carbide Schottky Diode

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**Abstract:** Silicon carbide (SiC) is the perfect cross between silicon and diamond. The crystal lattice of SiC is identical to silicon and diamond, but, exactly half the lattice sites are occupied by silicon atoms and half by carbon atoms. Like-diamond SiC has electronic properties superior to silicon, but, unlike diamond it is also manufacturable. The thermal leakage current (dark current) in SiC is sixteen orders-of-magnitude lower as well. As temperature increases, the leakage current increases, but, the temperature where the leakage current would disrupt circuit operation is over 1000 °C in SiC, compared to about 250 °C in silicon. The SiC electronic revolution began in the early 1990's when single-crystal wafers became commercially available for the first time. During the intervening years, many different electronic devices have been demonstrated in SiC, with performance often exceeding the theoretical limits of silicon. These include pin diodes, MOS field-effect transistors (MOSFETs), metal-semiconductor field-effect transistors (MESFETs), and bipolar transistors (BJTs), as well as specialized devices such as CCD imagers, Schottky diodes, static induction transistors (SITS) and impact-ionization- avalanche-transit-time (MATT) microwave oscillators. These early digital logic gates and linear elements are based on n-channel MOS technology, but, quickly followed by more sophisticated CMOS integrated circuits.

**Key words:** Silicon Schottky diode, Silicon Carbide Schottky diode, MOSFET

### I. Introduction

Semiconductor power devices, especially diodes play important role in switching response. Low power dissipation on the switching devices will give rise to highly efficient power electronic system. For example, if a semiconductor device operates in a linear mode such as in power amplifiers or in linear regulators, it is expected that some amount of energy will be lost in the power circuit before its energy reaches the output. High efficiency of power converter requires a minimal loss of this energy from source to load. One of the energy can be easily dissipated in the diodes in terms of heat leading to a lower efficiency of the converter [1].

The unipolar Silicon Schottky (Si) and Silicon carbide Schottky (SiC) diodes are commonly used in power converters circuits. In spite of both diodes come from the same unipolar family, the issues of higher switching losses with regards to reverse recovery losses have yet been solved. Nevertheless, the new SiC diode has emerged in the market in recent years where they are expected to improve the efficiency of the converter by allowing a further reduction in reverse recovery energy losses and hence increasing the performance. The additional substance of carbide element in the power Schottky diode may eventually lower the reverse charge current and thus, improve the overall transient response in the converter. An ideal semiconductor device would inhibit large breakdown voltage, low voltage drop in the on-state, high switching speed and low power loss. However in order to increase the performance of a semiconductor device, several additional doping enhancements will be added during the fabrication stage, where the characteristics of the device will altered by adding some impurity atoms to the pure semiconductor material. Today's technology requires extensive research to develop more powerful devices, not only to have lower switching losses, higher efficiency but also improve reliability. For this reason, power losses in the device must be put into consideration. The main contribution in this work is to verify that SiC high power diode having larger energy bandgap can indeed produce better results in DC-DC converter. The analyses are mainly done using circuit simulator.

### II. Silicon Schottky Diode Family

The Silicon Schottky diode of Schottky barrier diode is widely used as a mixer or detector diode. In addition to its low forward voltage drop, it may lead to lower levels of power losses in the circuit [2]. Since Si diode is a unipolar device, the current transport is mainly due to majority carriers and therefore the speed is faster. In addition, it has low turn-on voltage, high frequency capability and low capacitive effect [3]. SiC diode is a wide-bandgap (WBG) semiconductor family from III-V group. It has the advantages in faster recovery times as well as no dependence on temperature [4] and has the potential to operate more efficiently. In Si diode however, the temperature may rise due to the increasing in electron's thermal energy leading to higher peak reverse recovery current [5]. This eventually gives higher power loss in the device.

In addition to smaller package and higher weight, SiC diodes also have higher critical field and barrier heights compared to Si diode. This results in reduced on-state resistance and lower leakage current or SiC diode [6]. It also has been demonstrated that the SiC diode has the potential to improve power FET performance [7]. Its energy bandgap is three times higher than Si and ten times higher in electrical breakdown strength. Therefore, SiC can operate at operating voltage of 20 times with current densities up to 400 times higher than Si diode [8]. SiC Schottky diode has a small forward voltage and the reverse breakdown voltage cannot be made too high (currently about 200 V). It is used for rectification of power supplies for low voltage and high current applications or in high frequency systems due to its small reverse recovery time.

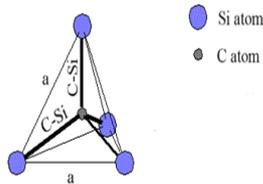


Fig.1 The tetragonal bonding of a carbon atom with the four nearest silicon neighbors. The distance  $a$  and C-SiC are approximately  $3.08\text{\AA}$  and  $1.89\text{\AA}$  respectively.

Fig. 1 shows four Si atoms made a covalent bonding with a single Carbon © atom to form a SiC. The C atom is located in the middle of the structure and the distances between all atoms which marked C-Si are equal. The SiC possess increase tolerance to radiation damage, marking it a material suitable for defense and aerospace applications. Due to high tolerance of temperature in SiC, it is chosen in various industries, such as aircraft, automotive communications, power and power spacecraft.

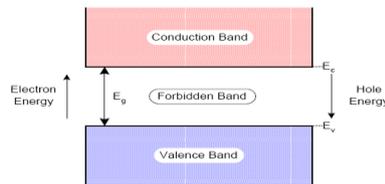
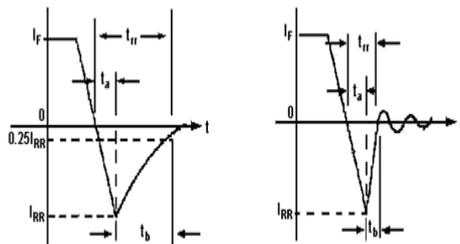


Fig. 2 Energy Band Diagram of a Semiconductor.

The characteristics of SiC diode as a wide bandgap semiconductor device results in a more energy to excite the electron from its covalent bond during turn-off compared to Si. Referring to Fig. 2, the wide bandgap is measured from the distance between the conduction band and valance band. An insulator would have a larger bandgap that would take lots of energy for the electrons to travel from the valence to conduction band while a conductor would have no forbidden band. The energy is calculated from the difference between both bands. The wider the bandgap, more thermal energy is required to excite the electrons enabling the device to operate at higher temperature without affecting its electrical properties.

### III. Reverse Recovery

Reverse recovery is one of the properties in a diode. It can be a factor in determining the efficiency of the applications. When a diode has been conducting in a forward bias long enough for it to establish steady, there will be charges due to the presence of minority charge carriers. This charge must be removed to block in reverse direction.



a. Soft recovery                      b. Abrupt recovery  
Fig. 3 Reverse Recovery Current Characteristic

The characteristics of reverse recovery current experienced by a diode is represented Fig. 3 above,  $t_{rr}$  represents the reverse recovery time,  $I_{rr}$  is the peak reverse current whilst  $t_a$  is the transition time due to charge stored in depletion region of the p-n junction and  $t_b$  is the time for the current to relax to zero. The peak reverse recovery current depends on the falling rate of change in current during turn-off. In SiC diode, there will be less or none reverse recovery current due to its ability to immediately remove stored charge. However, there are differences observed during the recovery from the peak values. This is merely reflected from different device's fabrication techniques.

Normally, in SiC, the rising current rate takes a longer time ( $t_{rr}$ ) as shown in part (a) in Fig 3. This eventually reduces the turn-off speed. In other SiC type, The speed can also be slightly faster due to smaller  $t_b$  but with the cost of higher dissipation. This can be seen in part (b) as oscillation exists during the end stage of turn-off time. In addition, if the falling current rate during the beginning of turn-off time is high as in the case of non-schottky diode, the reverse current would also be high, leading to both high power dissipation and lower in turn-off speed.

## IV. Diode characteristics

### 4.1 Static Characteristics

The I-V and reverse current are among the static characteristics of the device. Due to higher level of majority carrier injection in Si diode, this causes a lower voltage drop and hence smaller capacitance to bias the junction for turn-on process. This is the only advantages of Si diode compared to SiC. Here, SiC diode requires a higher voltage to forward bias the device. Apart from that, SiC diode can handle larger reverse voltage as compared to Si.

### 4.2 Dynamic Characteristics

The characteristic that changes with time is inherited in both devices. Si and SiC diodes are compared in terms of the reverse recovery time, reverse recovery current and corresponding switching losses. The comparisons in dynamic characteristics between two devices are tabulated in Table I. The SiC and Si diodes used are of part number UPSC600 and B530C respectively.

Table I. Comparison of Dynamic Characteristics

Characteristics	SiC Schottky (UPSC600)	Si Schottky (B530C)
Reverse Recovery Time	Time Unchanged with temperature variation	Increases as temperature increases
Reverse Recovery Current	Negligible	Increases as temperature increases
Switching Losses	Low	Slightly higher

Table I shows that SiC diode has advantages in all dynamic characteristics. Si diode suffers from higher reverse recovery current and switching losses. This clearly indicates that additional carbide substance in the device may improve switching speed and reduce power dissipation.

## V. Ac-Dc-Dc Converter (Chopper)

### 5.1 Simulation of DC-DC converter

Fig.4 shows the circuit diagram of AC-DC-DC converter, the LT spice simulation package is used for simulating this circuit. Table 2 give the properties of the active deviced in this circuit simulation. The input 230 V, 50 Hz 1 $\phi$  sine wave is with Rser resistance 1 $\Omega$ . The 1:1 power transformer selected to provide isolation in order to have competability with main pwer supply. Using MUR460 power diodes (D1-D4), bridge rectifier is constructed and capacitor C2 is connected across bridge rectifier output reduce the ac component. The switching device M1 (IXFX90N30) MOSFET used as switch. The gate pulse of amplitude 20 V with 25  $\mu$ sec.on period of 50  $\mu$ sec. total period is applied. Gate pulse Vg1 is shown in fig.5. The load for this circuit is used as inductive load with an inductance of 50  $\mu$ H and 55  $\Omega$ . The laod current for this circuit design is 275 mA with 50  $\mu$ sec duration and it is shown in fig.6. The output voltage across the R2 and L3 is show in fig.7 and fig. 8. shows the zoomed output at transition. The drain to source voltage of M1 is 108 volts to 228 volts which is shown in fig.9. The gate to source voltageof M1 is 0.5 volts to 2.5 volts which is shown in fig.10. The current through schottky diode D5 is 350 mA and switching loss of M1 is 235 W which are shown in fig.11 and fig.12.respectively. Fig.13 shows the switching loss of the schottky dioce D5 and is 40mW. The gate current of M1 is shown in fig.14 and is +1A during switch on and - 1A during turn off. The input to the circuit is shown in fig. 15 nad rectified voltage at across capacitor shown ing fig.16..

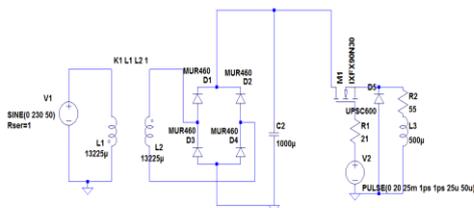


Fig.4 Circuit diagram AC-DC-DC converter

Table 2 Properties of the active devices used in the AC-DC-DC converter

Sl.No.	Recifier Diode MUR640	MOSFET IXFX()N30	Converter Diode UPSC600
Manufacturer	GI	IXYS	Microsemi
Polarity	Silicon	N-chan	Silcon Carbide Schottky
Vds[V]		300	
Rds[on][Ω]		0.033	
Qgate[C]		3.6e-007	
Average Current[A]	4		1
Breakdown Voltage[V]	600		600

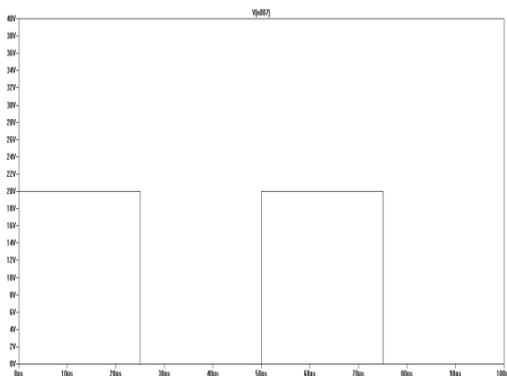


Fig. Fig.5. Gate Pulse Vg1

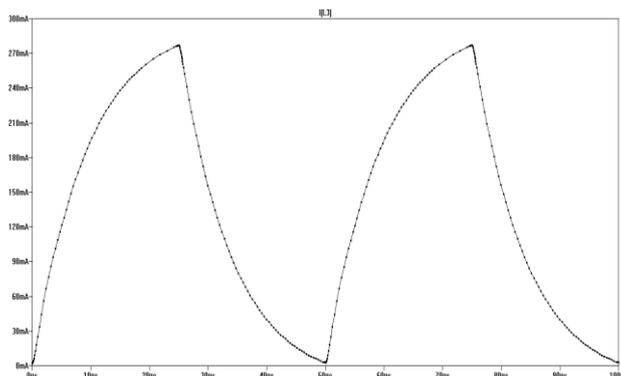


Fig. 6. Load Current

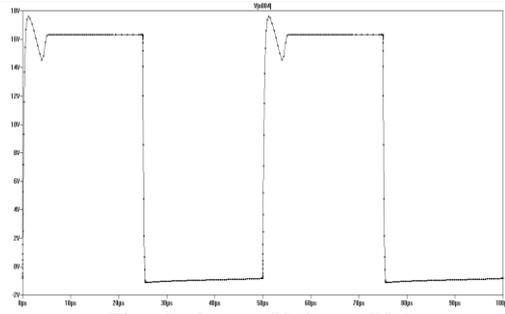


Fig. 7. Output Voltage (Vo)

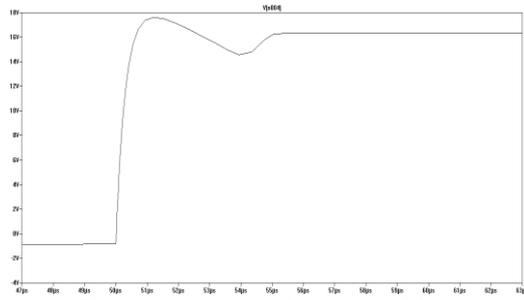


Fig. 8. Vo (zoomed near transition)

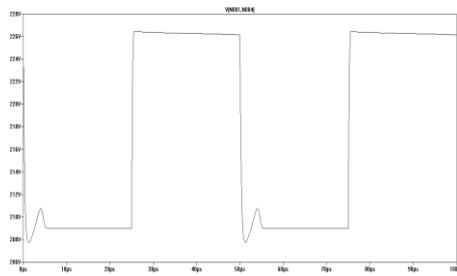


Fig. 9. Voltage Drain - Source

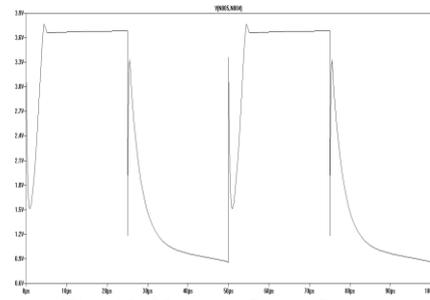


Fig. 10. Voltage Gate - Source

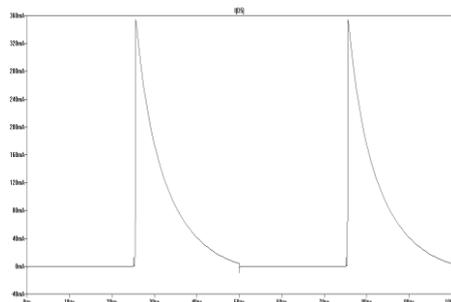


Fig. 11. Diode Current

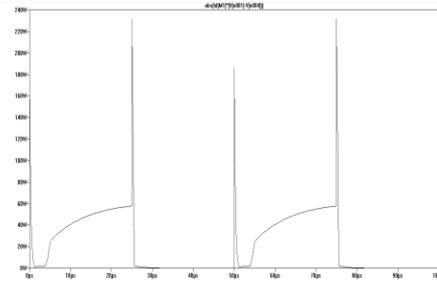


Fig.12 MOSFET Switching losses

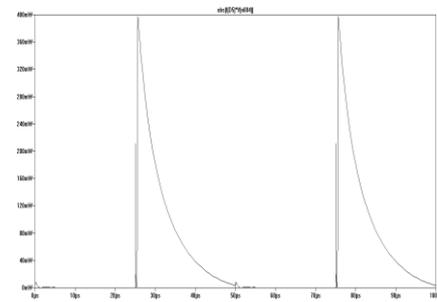


Fig. 13. Diode Switching Losses

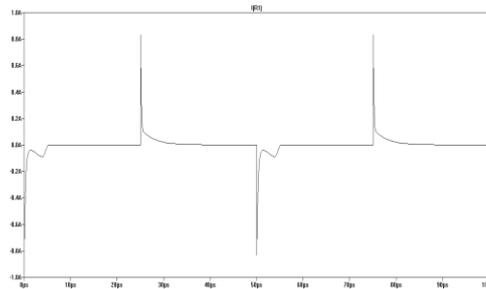


Fig. 14. Gate Current

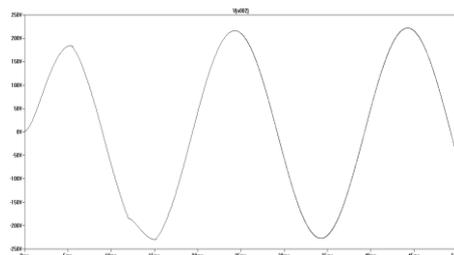


Fig.15. AC input voltage

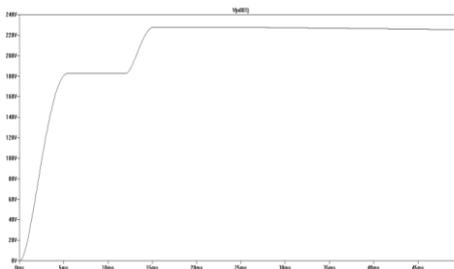


Fig.16. Rectified Voltage Across Filter

## 5.2 RESULTS AND DISCUSSIONS

Correct choice of diode is important in understanding its effects on the overall performance in AC-DC-DC converter. One of the effects is the voltage overshoot in the switch. Gate and drain voltages are prone to stress when diode suffers from high reverse recovery and hence may give rise to less switching speed and high dissipation in the circuit. Fig. 5 shows the forward overshoot in  $V_{gs}$  of  $M_1$  for SiC. Fig. 6 shows the load current

of SiC Schottky diode in the chopper circuit. The maximum swing of the currents is almost identical in value. However, the minimum peak is slightly greater for the SiC Schottky diode by merely 0.91 %. From this result, eventually, the output power can be calculated and compared. The MOSFET's  $V_{ds}$  overshoot is higher in SiC diode. This contradictory result makes the only drawback in the device. SiC has an overshoot voltage of 6 V, Which is 6 % higher than Si that only 6.5 V. This is caused by the charge removal response time in SiC where  $t_d$  is higher as previously shown in Fig. 3(a). Nevertheless, this results may not affect the improvement in the circuit because the variation in load circuit design may also cause to this drawback. Even though the MOSFET peak voltage overshoot in SiC chopper circuit is higher, the corresponding output power,  $P_{out}$  of the circuit is slightly lower. When MOSFET is turned off, load current will start to discharge through the diode and this overshoots the current further in the negative region before it goes back to zero mainly due to the removal of large amount of charges in the diode. The faster the removal of charge or the smaller of charge appeared in the diode will make the transient response faster.

Table 3 Current and Output Power

$R_{Load} = 55 \Omega$	SiC Schottky
$I_{R_{Load},min}$	8 mA
$I_{R_{Load},max}$	285 mA
$I_{R_{Load},avg}$	148 mA
$P_{out}$	2.664W

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### VI. Acknowledgment

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### Biographies



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